



Computer Vision and Pattern Recognition Techniques

Collection Editor:

Dr. Donghyeon Cho

Department of Electronics
Engineering, Chungnam National
University, Daejeon 34134,
Republic of Korea

Message from the Collection Editor

Dear Colleagues,

Recently, AI, machine learning, pattern recognition, and deep learning have been attracting attention in various fields of applications, such as autonomous driving, IoT, robot, drone, smart mobility, etc. These applications acquire data from the surrounding environment through sensing; they then analyze the acquired data, making decisions and actions based on the analysis. Vision sensors are mainly used to acquire data, thus, computer vision technology that analyzes and utilizes visual information is of great importance. The aims of this Special Issue are to provide a venue to publish various research about computer vision technologies based on AI, machine learning, pattern recognition, and deep learning. Specifically, our scope includes recognition tasks (including image classification, object detection, and segmentation), low-level vision tasks (including super resolution and image denoising), and tasks related to video and 3D vision.





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Editor-in-Chief

Prof. Dr. Flavio Canavero

Department of Electronics and
Telecommunications,
Politecnico di Torino, 10129
Torino, Italy

Message from the Editor-in-Chief

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Electronics Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland

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